



3742

PATENT
Customer No. 22,852
Attorney Docket No. 07043.0020

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Masahiro SHIMIZU et al.) Group Art Unit: 3742
)
Application No.: 10/085,092) Examiner: S. Fuqua
)
Filed: March 1, 2002)
)
For: HEAT TREATMENT APPARATUS)
USING A LAMP FOR RAPIDLY)
AND UNIFORMLY HEATING A)
WAFER)

RECEIVED

MAR 11 2004

TECHNOLOGY CENTER R3700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one-month extension of time to reply to the Office
Action of November 4, 2003. A fee payment of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge
any additional required fees to our Deposit Account No. 06-0916.

03/08/2004 MMEKONEN 00000069 10085092

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110.00 OP

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: March 4, 2004

By: David W. Hill
David W. Hill
Reg. No. 28,220